

03500.014055.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
NOBUHIRO ITO ET AL.) Examiner: S. Roy
Appln. No.: 09/413,774) Group Art Unit: 2879
Filed: October 7, 1999)
For: ELECTRON BEAM)
APPARATUS AND SPACER) March 5, 2003

The Commissioner for Patents
Washington, D.C. 20231

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SUPPLEMENTAL AMENDMENT

Sir:

Supplemental to the Amendment filed in the Patent and Trademark Office on
February 19, 2003 and the Supplemental Remarks filed on February 24, 2003, please
further amend the above-identified application as follows:

IN THE CLAIMS

Please add Claims 113-122 to read as follows:

113. (New) An electron beam apparatus comprising a hermetic container
which includes an electron source having electron emission devices and targets exposed to
electrons emitted from said electron source and further comprising a first member within
said hermetic container, wherein said first member is provided with an uneven geometry on